

00684.103076

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: M. Liu
Natsuhiko MIZUTANI	)	
	:	Group Art Unit: 2851
Application No.: 10/529,893	)	
	:	Confirmation No.: 7796
35 U.S.C. § 371(c)	)	
Completion Date: October 17, 2005	:	
	)	August 15, 2007
For: NEAR-FIELD EXPOSURE METHOD AND	:	
APPARATUS, NEAR-FIELD EXPOSURE	)	
MASK, AND DEVICE MANUFACTURING	:	
METHOD	)	

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT & SUBMISSION OF  
SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated July 10, 2007, please amend the above-identified application as follows: